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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/936,683	11/30/2001	Kazuyuki Tadatomo	213578	8963

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EXAMINER

ERDEM, FAZLI

ART UNIT

PAPER NUMBER

2826

DATE MAILED: 11/20/2002

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary	Application No.	Applicant(s)
	09/936,683	TADATOMO ET AL.
	Examiner Fazli Erdem	Art Unit 2826

The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM

**A SHORTENED STATUTORY PERIOD FOR REPLY
TO THE MAILING DATE OF THIS COMMUNICATION**

THE MAILING DATE OF THIS COMMUNICATION: Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.

- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

1) Responsive to communication(s) filed on 17 October 2002 .

2a) This action is **FINAL**. 2b) This action is non-final.

3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

4) Claim(s) 1-21 is/are pending in the application.
4a) Of the above claim(s) 11-21 is/are withdrawn from consideration.

5) Claim(s) _____ is/are allowed.

6) Claim(s) 1-10 is/are rejected.

7) Claim(s) _____ is/are objected to.

8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on _____ is/are: a) accepted or b) objected to by the Examiner.

Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

11) The proposed drawing correction filed on _____ is: a) approved b) disapproved by the Examiner.

If approved, corrected drawings are required in reply to this Office action.

12) The oath or declaration is objected to by the Examiner.

Priority under 35 U.S.C. §§ 119 and 120

13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).

a) All b) Some * c) None of:

1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. _____.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).

a) The translation of the foreign language provisional application has been received.

15) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.

Attachment(s)

1) Notice of References Cited (PTO-892)
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)
3) Information Disclosure Statement(s) (PTO-1449) Paper No(s) _____

4) Interview Summary (PTO-413) Paper No(s). _____
5) Notice of Informal Patent Application (PTO-152)
6) Other: _____

DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

1. Claims 1, 3, 5-10 rejected under 35 U.S.C. 103(a) as being unpatentable over Vichr et al. (5,614,019) in view of Kawasumi et al. (JP 10178026 A) further in view of Shigeta et al. (5,729,701) further in view of Usui et al. (6,252,261).

Regarding Claims, 1, 3, 5-10, Vichr et al. show a method for the growth of industrial crystals where a method of producing large single crystals is disclosed. Furthermore Vichr et al. show the substrate and concavo-convex structure. Vichr et al. do not show the selective growth of crystals on the concave part of the substrate, nor the specific directional growth configuration. However, Kawasumi et al. disclose a crystal growth method and method for manufacturing semiconductor luminescent element utilizing the same where the selective growth of crystals on the concave part of the substrate is disclosed. Furthermore, Shigeta et al. disclose a method for the growth of silicon carbide single crystals where the directional structure is disclosed and Usui et al. disclose a GaN crystal film, a group III element nitride semiconductor wafer and a manufacturing process therefore where the crystal specific crystal configuration is shown.

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the selective growth, directional, and configurational structure of crystal growth in Vichr et al. as taught by Kawasumi et al., Shigeta et al., and Usui et al.,

respectively in order to provide a semiconductor crystal growth structure with high controllability.

2. Claims 2 and 4 rejected under 35 U.S.C. 103(a) as being unpatentable over Vichr et al. (5,614,019) in view of Kawasumi et al. (JP 10178026 A) further in view of Shigeta et al. (5,729,701) further in view of Usui et al. (6,252,261) further in view of Vaudo et al. (6,156,581).

Regarding Claims 2 and 4, Kawasumi et al., Shigeta et al., and Usui et al., combination disclose all the claimed subject matter except they fail to show the InGaAlN structure. However, Vaudo et al. disclose a GaN-based devicees using (Ga, Al, In)N base layers.

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the InGaAlN structure in Kawasumi et al., Shigeta et al., and Usui et al., combination as taught by Vaudo et al. in order to have a semiconductor crystal structure with better device quality.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Fazli Erdem whose telephone number is (703) 305-3868. The examiner can normally be reached on M - F 8:00 - 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (703) 308-6601. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7724 for After Final communications.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

FE
November 18, 2002

NATHAN J. FLYNN
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800